

REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2813

Attorney Docket: 040008-0307078
Client Reference: OF03P195/US

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JUN 28 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of: LEE Confirmation Number: 8236

Application No.: 10/733,276 Group Art Unit: 2813

Filed: December 12, 2003 Examiner: Nguyen, Thanh T.

Title: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITHOUT
OXIDIZED COPPER LAYER (AS AMENDED)

*Expedited
w/ LCE
7.28.05*

AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116

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Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 30, 2005, please amend the above-identified application as follows:

7/28/05

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PAGE 613*RCVD AT 6/28/2005 4:44:28 PM (Eastern Daylight Time)*SVR:USPTO-EXRF-15*OVS:8729305*CSID:4703-805-2500*DURATION (mm:ss):03:42